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TRANSMITTAL FORM

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Application Number	10/714,088
Filing Date	November 14, 2003
First Named Inventor	Sidlgata V. Sreenivasan
Art Unit	Unassigned
Examiner Name	Unassigned
Attorney Docket Number	P69-11-03

Total Number of Pages in This Submission: 4

ENCLOSURES *(Check all that apply)*

- ☐ Fee Transmittal Form
  - ☐ Fee Attached
- ☐ Amendment/Reply
  - ☐ After Final
  - ☐ Affidavits/declaration(s)
- ☐ Extension of Time Request
- ☐ Express Abandonment Request
- ☑ Information Disclosure Statement
- ☐ Certified Copy of Priority Document(s)
- ☐ Response to Missing Parts/ Incomplete Application
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: McMackin et al. PATENT APPLICATION
Serial No.: 10/714,088 Group Art Unit: Unassigned
Filing Date: October 2, 2003 Examiner: Unassigned
For: DISPENSE GEOMETRY TO ACHIEVE HIGH SPEED FILLING AND THROUGHPUT

INFORMATION DISCLOSURE STATEMENT

Commissioner
for Patents
Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. Form PTO-1449 and a copy of each reference recited below accompanies this document. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

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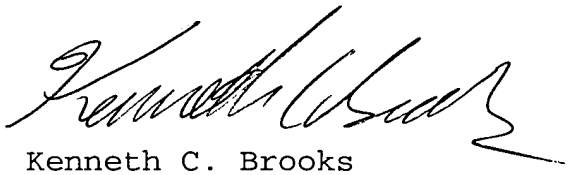

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet	1	of	6

Complete if Known	
Application Number	10/714,088
Filing Date	11/14/2003
First Named Inventor	McMackin et al.
Group Art Unit	Unassigned
Examiner Name	Unassigned
Attorney Docket Number	P69/MII-29-11-03

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	U.S. Patent Document Number	U.S. Patent Document Kind Code[2] (*if known*)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	B1	3,827,027		Heisler	04-30-1974	
	B2	3,807,029		Troeger	04-30-1974	
	B3	3,811,665		Seelig	05-21-1974	
	B4	4,062,600		Wyse	12-13-1977	
	B5	4,098,001		Watson	07-04-1978	
	B6	4,155,169		Drake et al.	05-22-1979	
	B7	4,202,107		Watson	05-13-1980	
	B8	4,337,579		De Fazio	07-06-1982	
	B9	4,355,469		Nevins et al.	10-26-1982	
	B10	4,414,750		De Fazio	11-15-1983	
	B11	4,440,804		Milgram	04-03-1984	
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	B14	4,694,703		Routson	09-22-1987	
	B15	4,763,886		Takei	08-16-1988	
	B16	4,929,083		Brunner	05-29-1990	
	B17	4,959,252		Bonnebat et al.	09-25-1990	
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	B19	5,110,514		Soane	05-05-1992	
	B20	5,126,006		Cronin et al.	06-30-1992	
	B21	5,204,739		Domenicali	04-20-1993	
	B22	5,240,550		Boehnke et al.	08-31-1993	
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	B27	5,515,167		Ledger et al.	05-07-1996	
	B28	5,545,367		Bae et al.	08-13-1996	
	B29	5,566,584		Briganti	10-22-1996	
	B30	5,633,505		Chung et al.	05-27-1997	
	B31	5,723,176		Keyworth et al.	03-03-1998	
	B32	5,753,014		Van Rijn	05-19-1998	
	B33	5,760,500		Kondo et al.	06-02-1998	
	B34	5,802,914		Fassler et al.	09-08-1998	

Examiner Signature		Date Considered	

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Sheet	2	of	6

Complete if Known	
Application Number	10/714,088
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First Named Inventor	McMackin et al.
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	B35	5,877,036		Kawai	03-02-1999	
	B36	5,877,861		Ausschnitt et al.	03-02-1999	
	B37	5,888,650		Calhoun et al.	03-30-1999	
	B38	5,942,871		Lee	08-24-1999	
	B39	5,948,470		Harrison et al.	09-07-1999	
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	B48	6,143,412		Schueller et al.	11-07-2000	
	B49	6,168,845		Fontana, Jr. et al.	01-02-2001	
	B50	6,204,922		Chalmers	03-20-2001	
	B51	6,234,379		Donges	05-22-2001	
	B52	6,245,213		Olsson et al.	06-12-2001	

Examiner Signature		Date Considered	

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Attorney Docket Number	P69/MII-29-11-03

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	B53	DE	2800476		Lamprecht et al.	07-13-1978		
	B54	WO	92/17883		Olsson	10-15-1982		
	B55	EP	244884		Ponjee	03-03-1987		
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	B63	WO	01/33300		Choi	05-10-2001		

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 4 of 6

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First Named Inventor	McMackin et al.
Group Art Unit	Unassigned
Examiner Name	Unassigned
Attorney Docket Number	P69/MII-29-11-03

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
	B64	STEWART, "A Platform with Six Degrees of Freedom," Proc. of Inst. Mech. Engrs., 1965, pp. 371-378, vol. 180 pt. 1, no. 15.	
	B65	PAROS et al., "How to Design Flexure Hinges," Machine Design, Nov. 25, 1965, pp. 151-156.	
	B66	RAIBERT et al., "Hybrid Position/Force Control of Manipulators," Transactions of the ASME, Journal of Dynamic Systems, Measurement and Control, June 1981, pp. 126-133, vol. 102.	
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	B69	HOLLIS et al., "A Six-Degree-of-Freedom Magnetically Levitated Variable Compliance Fine Motion Wrist: Design, Modeling and Control," IEEE Transactions on Robotics and Automation, 1991, pp. 320-332, vol. 7, no. 3.	
	B70	TOMITA et al., "A 6-Axes Motion Control Method for Parallel-Linkage-Type Fine Motion Stage," Journal of Japan Society of Precision Engineering, 1992, pp. 118-124.	
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Examiner Signature		Date Considered	

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Sheet	5	of	6

Complete if Known	
Application Number	10/714,088
Filing Date	11/14/2003
First Named Inventor	McMackin et al.
Group Art Unit	Unassigned
Examiner Name	Unassigned
Attorney Docket Number	P69/MII-29-11-03

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
	B75	MERLET, "Parallel Manipulators: State of the Art Perspectives," Advanced Robotics, 1994, pp. 589-596, vol. 8.	
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Sheet 6 of 6

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Application Number	10/714,088
Filing Date	11/14/2003
First Named Inventor	McMackin et al.
Group Art Unit	Unassigned
Examiner Name	Unassigned
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	B86	TAJBAKHSH et al., "Three-Degree-of-Freedom Optic Mount for Extreme Ultraviolet Lithography," ASPE, 1998, pp. 359-362, vol. 18.	
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